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To Examiner T. Pham, Group Art Unit 2823, U.S.P.T.O.

Fax no. 571-273-8300 Phone no. \_\_\_\_\_

From Mitchell W. Shapiro Phone no. 703-610-8652

Date October 12, 2005 Time \_\_\_\_\_  
File no. Our Ref: XA-9907 Pages including cover 17

Re: U.S. Patent Appln. No. 10/616,923

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XA-9907  
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of:

Haruki FUKAI et al.

Appln. No.: 10/616,923

Group Art Unit: 2823

Filed: July 11, 2003

Examiner: T. Pham

For: SEMICONDUCTOR LASER DEVICE HAVING REDUCED CONTACT  
RESISTANCE AND MANUFACTURING METHOD THEREOF (AS AMENDED)

\* \* \*

AMENDMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Sir:

In response to the Office Action mailed on July 12, 2005, please amend the above-identified patent application as indicated below.

Amendments to the specification begin on page 2 of this paper.

Amendments to the claims begin on page 3 of this paper.

Remarks begin on page 13 of this paper.